

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79007

Koichi KAWAMURA, et al.

Appln. No.: 10/735,769

Group Art Unit: 1756

Confirmation No.: 3973

Examiner: Daborah Chacko Davis

Filed: December 16, 2003

For: PATTERN FORMING METHOD AND SUBSTANCE ADHERENCE PATTERN
MATERIAL

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

A petition and the required fee are submitted herewith for a one (1) month extension to extend the time period for reply to the Office Action dated September 25, 2006 from December 25, 2006 to January 25, 2007.

In response to the Office Action dated September 25, 2006, please amend the above-identified application as follows on the accompanying pages.

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